



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Mohamed N. Darwish
Assignee: Siliconix incorporated
Title: Trench MOSFET Having Implanted Drain-Drift Region And Process
For Manufacturing The Same
Serial No.: 10/650,513 Filing Date: 8/27/2003
Examiner: Unknown Group Art Unit: 2812
Docket No.: SCX010-5D US Confirmation No: 5781

Santa Clara, California
January 15, 2004

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the documents listed on the accompanying Form PTO-1449. Copies of references numbered 20-28 are submitted herewith. The Examiner is requested to make these documents of record. The remaining references are not attached as this application was filed after June 30, 2003.

This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(b) as it within three months of the filing date of a national application other than a continued prosecution application and/or before the mailing of a first Office Action on the merits. Accordingly, no fee is required.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

In addition, Applicants submit for the Examiner's consideration the following list of co-pending and co-owned applications, cited by serial number, first named inventor and filing date. The Applicants presume that the Examiner has access to and will review the co-

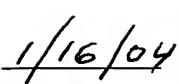
SILICON VALLEY
PATENT GROUP LLP

2350 Mission College Blvd.
Suite 360
Santa Clara, CA 95054
(408) 982-8200
FAX (408) 982-8210

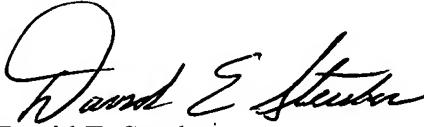
pending applications and the files thereof for any office actions, amendments or other materials that may be relevant to the patentability of the claims of the present application. For any such U.S. patent application(s) that are currently pending, the Applicants further presume that the Examiner will consider any future office actions, amendments or other materials in the file thereof that may be relevant to the patentability of the claims herein. **If the Applicants' understanding in this regard is not correct, please notify the undersigned so that copies of any such documents can be submitted to the Examiner.**

	Serial No.:	First Named Inventor	Date:
1.	09/927,143	Mohamed N. Darwish	08/10/01
2.	10/106,812	Mohamed N. Darwish	03/26/02
3.	10/106,896	Mohamed N. Darwish	03/26/02
4.	Attorney Docket No. SCX005-3P US (Serial # unknown)	Mohamed N. Darwish	11/25/03
5.	10/317,568	Mohamed N. Darwish	12/12/02
6.	10/326,311	Mohamed N. Darwish	12/19/02
7.	10/454,031	Mohamed N. Darwish	06/04/03

The information contained in this Information Disclosure Statement under is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

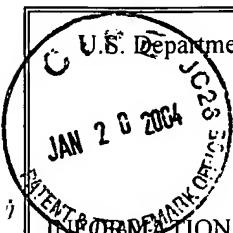
CERTIFICATE OF MAILING BY "FIRST CLASS"	
I hereby certify that this paper or fee is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the below date.	
	
Attorney for Applicant(s)	Date of Signature

Respectfully submitted,



David E. Steuber
Attorney for Applicant(s)
Reg. No. 25,557

SILICON VALLEY
PATENT GROUP LLP
2350 Mission College Blvd.
Suite 360
Santa Clara, CA 95054
(408) 982-8200
FAX (408) 982-8210

 INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		Application No.:	10/650,513
		Filing Date:	08/27/2003
		First Named Inventor:	Mohamed N. Darwish
		Group Art Unit:	2812
		Examiner Name:	Unknown
		Confirmation No.:	5781
		Attorney Docket No.:	SCX010-5D US

U.S. Patent Documents

*Examiner Initials	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	1. 5,442,214	8/15/95	Yang	257	328	
	2. 5,915,180	8/22/99	Hara et al.	438	270	
	3. 6,444,528	9/03/02	Murphy	438	270	
	4. 5,882,971	03/16/99	Wen	438	276	
	5. 5,424,231	06/13/95	Yang	437	40	
	6. 5,976,936	11/02/99	Miyajima	438	268	
	7. 5,486,714	01/23/96	Hong	257	321	
	8. 4,914,058	04/03/90	Blanchard	437	203	
	9. 4,967,245	10/30/90	Cogan et al.	357	23.4	
	10. 4,683,643	08/04/87	Nakajima et al.	437	203	
	11. 5,473,176	12/05/95	Kakumoto	257	192	
	12. 6,020,600	02/01/00	Miyajima et al.	257	76	
	13. 6,074,909	06/13/00	Gruening	438	242	
	13. 6,144,054	11/07/00	Agahi et al.	257	296	
	15. 6,291,298	09/18/01	Williams et al.	438	270	
	16. 6,084,264	07/04/00	Darwish	257	329	
	17. 6,569,738 B2	05/27/03	Darwish	438	270	
	18. 4,546,367	10/08/85	Schutten et al	357	23.4	
	18. 0026989 A1	10/04/01	Thapar	438	400	

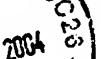
Foreign Patent Documents

						Translation		
		Document	Date	Country	Class	Subclass	Yes	No
	20.	WO-98/04004	01/29/1998	PCT				
	21.	JP-1-192174A	08-02-1989	Hitachi				X
	22.	EP-0 801 426 A2	10-15-1997	Harris				

Examiner:

Date Considered:

* Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication with applicant.

 <p>U.S. Department of Commerce, Patent and Trademark Office</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)</p>	Application No.:	10/650,513
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	First Named Inventor:	Mohamed N. Darwish
	Group Art Unit:	2812
	Examiner Name:	Unknown
	Confirmation No.:	5781
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	23.	JP-3-211885	09-17-1991	Matsushita				X
	24.	JP-11-163342	06-18-1999	NEC				X
	25.	JP-6-21468	01-28-1994	Japan				X

Non Patent Literature Documents

Examiner: _____ **Date Considered:** _____

* Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication with applicant.